

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application:

Hideki IWAKI et al.

Group Art Unit: 2841

Serial No.: New Divisional Application

Examiner: Q. Vu

Filed: November 28, 2001

For:

MULTI-LEVEL CIRCUIT SUBSTRATE, METHOD FOR MANUFACTURING SAME AND METHOD FOR ADUSTING A CHARACTERISTIC IMPEDANCE THEREFOR

Commissioner of Patents Washington, D.C. 20231

PRELIMINARY AMENDMENT

Sir:

Prior to initial examination, please amend the above-identified patent application as

follows.

IN THE CLAIMS:

Please cancel claims 12-14 without prejudice or disclaimer.

New Divisional Application Attorney Docket No.: P64916US1

REMARKS

By this Preliminary Amendment, claims 12-14 are canceled without prejudice or disclaimer.

Respectfully submitted,

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